

	INDIAN INSTITUTE OF TECHNOLOGY MADRAS Chennai 600 036 Telephone: [044] 2257 9798 E-mail: tender@imail.iitm.ac.in	
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25.02.2021

Department of Electrical Engineering

Corrigendum-1

Tender Reference no: EE/2021/043/ENAK/PEALD SYSTEM

Name of the Item: Plasma enhanced Atomic Layer Deposition (PEALD) system suitable for deposition of Al₂O₃, AlHfO, AlN, SiO₂ and SiN

Corrigendum details: Changes in technical specification & Extension of Bid Submission Date

Changes in technical specification:

S.No	Current Specification	Revised Specification
1.	<p><u>System:</u></p> <p>Chamber made from single metal block with integrated heating for easy opening and closing of chamber (no bolts that need be removed). Removable inner chamber/liners for easy maintenance</p>	<p><u>System:</u></p> <p>Chamber made from single metal block with integrated heating for easy opening and closing of chamber. Removable inner chamber/liners for easy maintenance</p>

Extension of Bid Submission Date:

The due date for the submission of bids has been extended to 11/03/2021 @ 5 PM & the technical bid opening is 12/03/2021 @ 4 PM

Tender Inviting Authority:

The Senior Manager, Project Purchase,
 IC&SR Building, IIT Madras
 Chennai 600036